

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re PATENT APPLICATION of

Yukio Narukawa et al. : Group Art Unit: 2814  
Application No. 10/687,768 : Examiner: Trinh, Hoa B.  
Filed: October 20, 2003 : Confirmation No.: 9596

Title: NITRIDE SEMICONDUCTOR DEVICE, AND ITS FABRICATION  
PROCESS

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**AMENDMENT**

U.S. Patent and Trademark Office  
Customer Service Window, **Mail Stop Amendment**  
Randolph Building  
401 Dulany Street  
Alexandria VA 22314

Madam:

In response to the Office Action dated March 30, 2007, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

**Amendments to the claims** begin on page 2 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.